

<b>Notice of References Cited</b>	Application/Control No. 10/806,269	Applicant(s)/Patent Under Reexamination SIPPOLA, MIKA	
	Examiner Marcos D. Pizarro-Crespo	Art Unit 2814	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,225,688	05-2001	Kim et al.	257/686
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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**FOREIGN PATENT DOCUMENTS**

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